

Laser monitoring: hardware



The Laser workshop

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CERN, September 16 2005

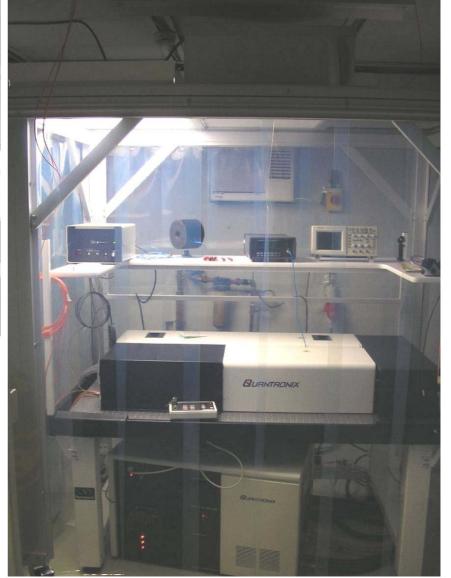


I Laser monitoring: hardware





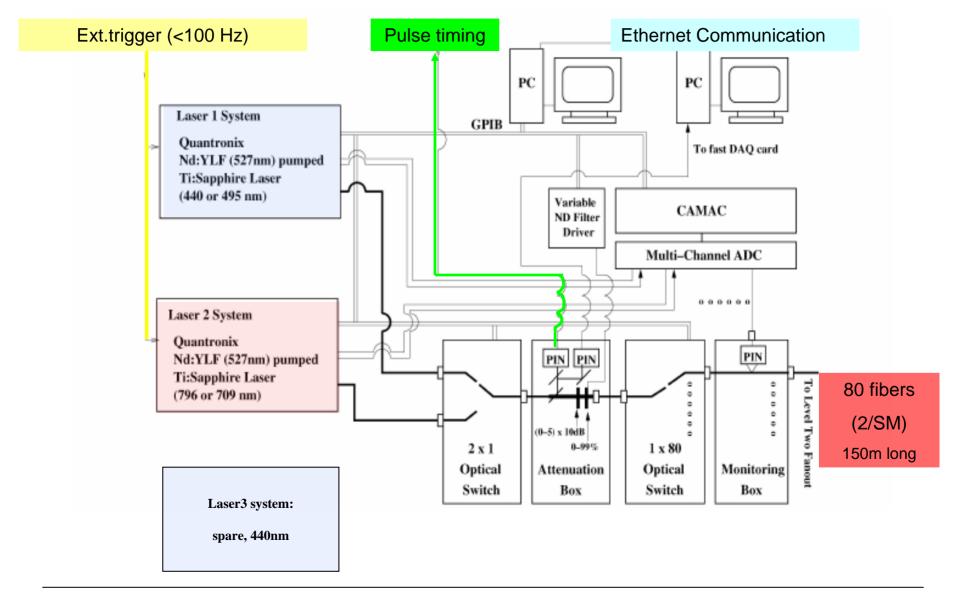
The system is design to continuously monitor the ECAL in situ at CMS





I Light source and high level distribution

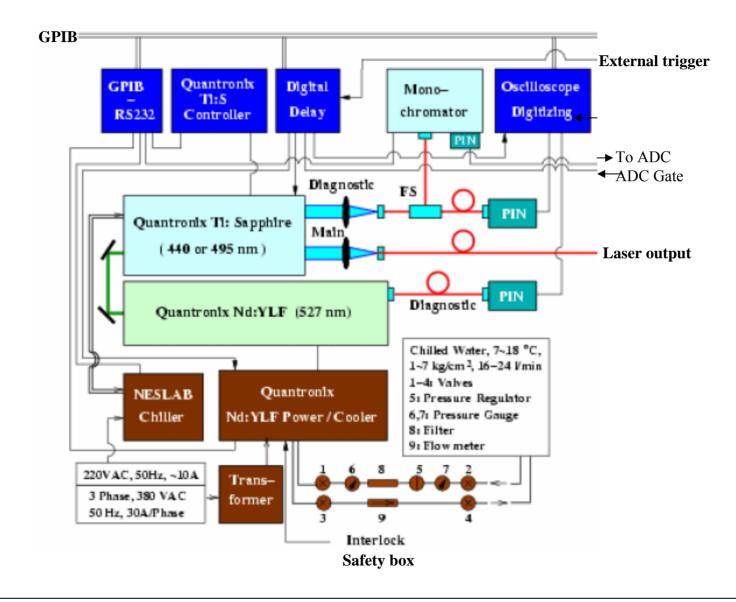






I Details of One Laser System

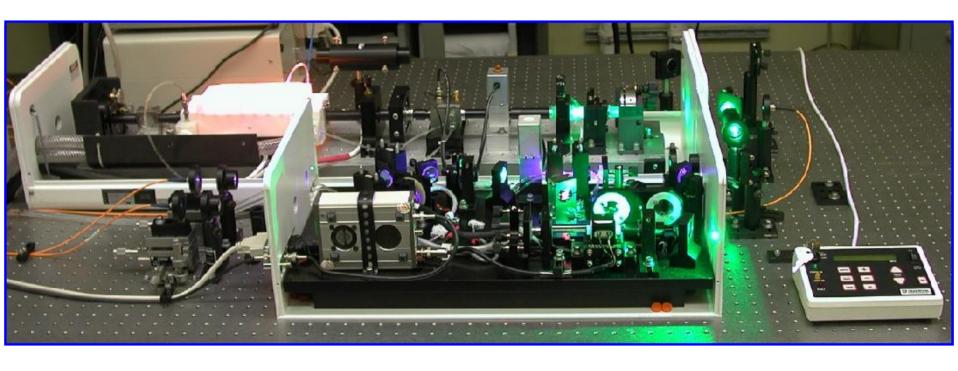


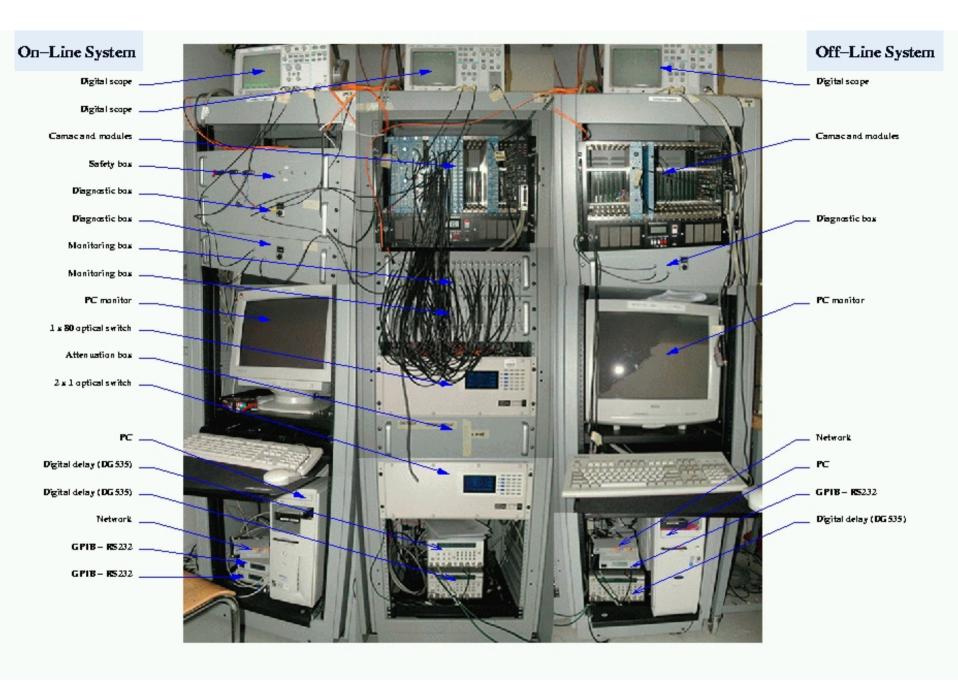




I Quantronix Laser









I Laser Specifications & Environment



ECAL specifications:

 \implies 2 wavelengths: - one close to the emission peak \rightarrow best monitoring linearity (440 nm)

- one to monitor readout electronics chain from the APD to the ADC (796 nm)

 \implies Pulse jitters: < 4ns/2ns for long (24 h) / short (0.5 h) term

Pulse width: < 40ns

Pulse energy: 1 mJ/pulse (>1TeV equivalent energy deposition in each crystal).

100-170

Pulse rate: <100 Hz Intensity instability: <10%

Quantronix laser:	YLF*	Ti:S 1		Ti:S	S 2	
λ (nm)	527	440	495	796	709	
Pulse energy (m.I	20	1 (0.5	1.5	0.42	

25-30

40-50

25-30

30

Pulse width (ns)

Environment:

cleanroom class <10,000: done since May 2005

temperature stabilized to ± 0.5 °C: to be done in CMS (ALEPH Air-Conditioning Unit)

Humidity <60%: to be done in CMS

^{*}YLF = Yttrium Lithium Fluoride



I Electronic cable connections



Input/Output laser barrack:

Ethernet: IN/OUT
Communication with XDAQ & DIM
DNS server

External trigger: INPUT (XDAQ)
Use to generate YLF laser pulse
< 100 Hz, TTL

<u>Level 2 TTL for safety</u>: <u>INPUT</u> from MEM to safety crate, 5V

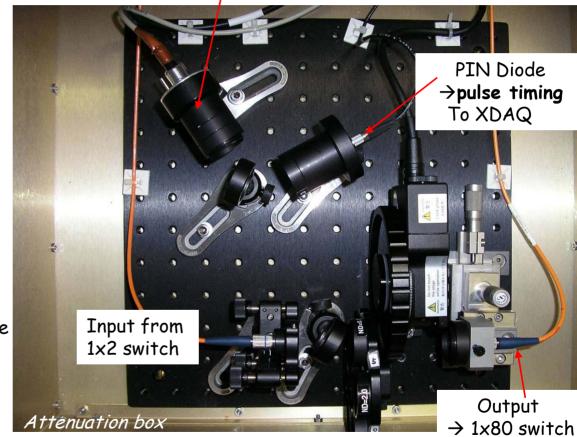
<u>Pulse timing</u>: <u>OUTPUT (XDAQ)</u> Laser pulse digitalized: inform when pulse

has been sent to SM.

Before 1x80 switch (Before 150m long fibers)

PIN Diode detector

→ Pulse to Acgiris DP210 & Matacq

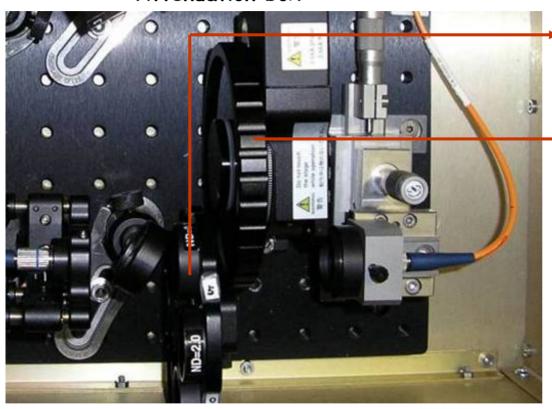




I Laser pulse intensity adjustment



Attenuation box:



Neutral density filters:

0-10-20-30-40-50 dB

+

Variable Reflective Neutral Density Filters



Optical Density from 0.04 - 2.7

 $\int_{\mathbb{R}^{n}}$

Remote control (XDAQ): 1% by 1%

0% = min. power (27 dB loss)

100% = max power (0.4 dB)



I Laser safety



Laser safety: → Limited access to the barrack

All the safety is controlled by the safety box:

• Outer door: - interlock + flash lamp + 3 LED

• Inner doors: - 3 interlocks

- 3 boxes: Flash LED+ yellow LED

· Level 2 TTL from MEM box:

→ low level if the laser pulse does not reach level 2 fanouts (e.g., accidentally broken fiber)

→ high level if the level 2 fanouts receive laser pulse.



2 modes of operation:

- Normal operation: inner doors should be closed and you can enter in the barrack without closed the shutter
- 2) Maintenance operation: inner doors can stay opened to work on the laser, then the outer door controls the shutters



CLASS 4



II Laser hardware maintenance

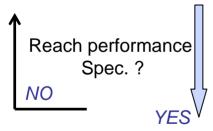


- Check the chilled water, change filter if it is too dirty
- Check the internal cooling water level (distilled water)
- Change the deionizing cartridge and the particle filter in the internal cooling unit (90 days)
- Check Neslab water level for Ti:S LBO
- Change YLF lamp every 500 to 1000 hrs (20 to 40 days).



Check YLF & Ti:S pulses

→ tuning, calibration, short run in internal trigger mode



Would need to readjust the attenuation, Controlled by the Laser Supervisor







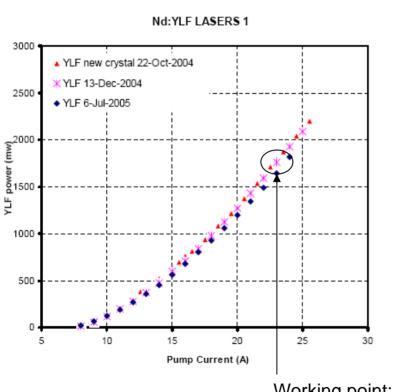
II Laser calibration

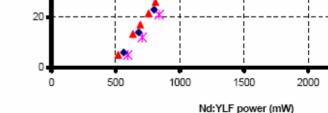


<u>Laser main controls:</u> **YLF:** pump current

Ti:S: pulse delay: ~5ns max./YLF pulse (+optics tuning, HV Q-switch)

TI: Sapphire power (mw)





440nm 6-Jul-2005

Nd:YLF LASER PUMPED TI:S LASERS 1

Working point: 23A

2500

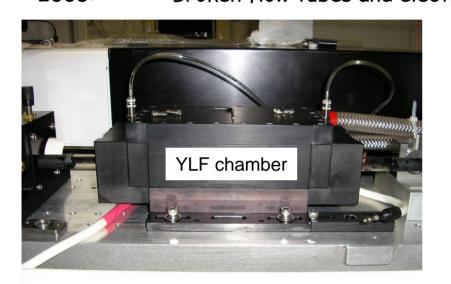


II Experience with hardware failures



Since 2004: Optics damage caused by dirty environment, broken flow tubes.

2005: Broken flow tubes and electronics: mother board of 1x80 switch



Life time:

- lamp: ~ 1000 hrs → Lamp aging: **0.5% daily**
- flow tube: 1 year
- gold reflector: to be checked every year





III Laser pulse monitoring



3 monitoring systems: - SLOW (DSO for each laser system)

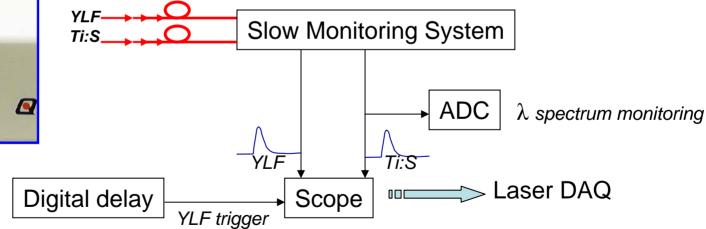
- 2 FAST (Acqiris DP210 & Matacq)

Slow monitoring:

- →Control lasers setup,
- →Check YLF and Ti:S performance at 1Hz,
- → Keep laser history for diagnostics.



Laser diagnostic output





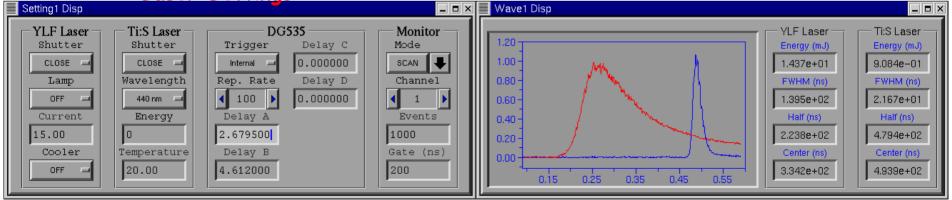
III Laser DAQ control display





Laser Settings

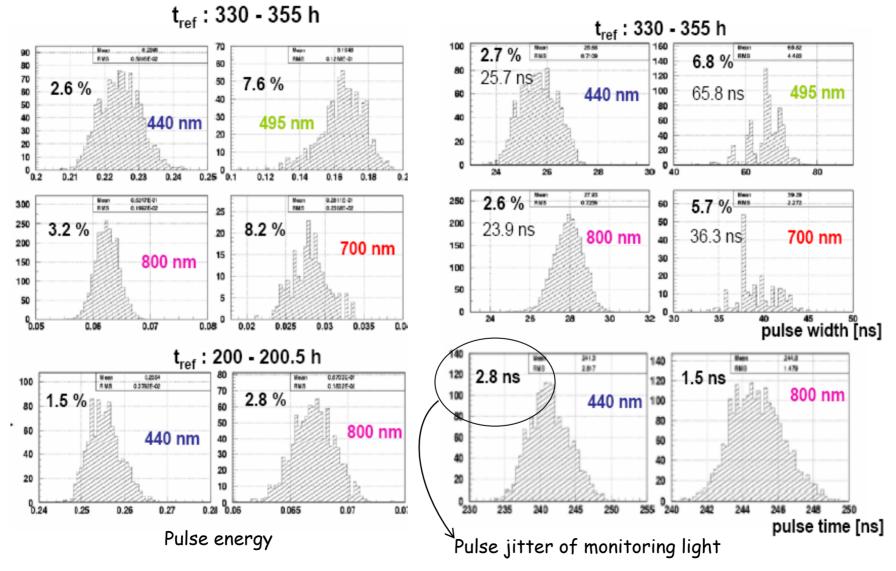
Waveform Display





III Result of the slow monitor: Intensity, FWHM, Timing

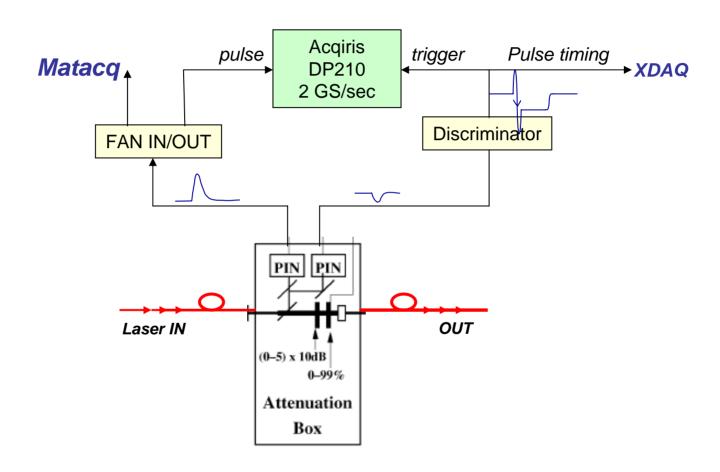






III Fast Monitoring: Acqiris DP210 and Matacq





MATACQ: Fast acquisition card developed by **CEA/Saclay**, IN2P3/LAL Sample frequency: 1GHz, 2GHz in boosted mode.



III Acqiris DP210 Card (2G5/s, 2004)



To follow Ti:S performance pulse by pulse

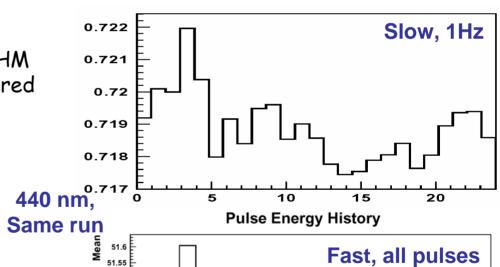


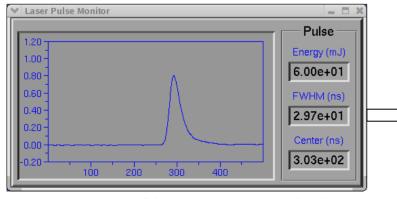
Fast sampling ADC (2 GS/s) on one PC

→ Acqiris DP210, PCI card with oscilloscope
characteristics, 500MHz BW, 8bit



Record all Ti:S pulses: Intensity & FWHM No laser timing information: self-triggered





Option: filter 60MHz available

51.45

51.4

51.35

20

Time Hours

17.5



IV Communication with ECAL: Laser Supervisor



Communication with the XDAQ: through Ethernet.

At the beginning of each run, the DAQ sets and checks laser parameters by sending a command file, and the laser responds to the DAQ by sending an acknowledge file.

Laser parameters controlled by XDAQ:

- -laser wavelength (change: ~1 min. if on same laser),
- -linear attenuator,
- -output channel number of the 1x80 optical switch.



IV Communication protocol



1. The command file from the H4 DAQ to the laser:

COMMAND TYPE (int) 0: request laser parameters

1: set laser parameters

2: get laser parameters and pulse information

WAVELENGTH (int) 0: 440 nm

1: 495 nm 2: 709 nm

2: 709 nm 3: 800 nm

ATTENUATOR (int) 1 – 99 % of laser power, in 1% step

SWITCH CHANNEL (int) 1 - 80

CHECK-SUM (int) Bitwise inversion of the sum of preceding 4 data

2. The acknowledge file from the laser to the DAQ:

COMMAND TYPE (int) 0: setting in progress

1: setting finished, the laser parameters are ready

WAVELENGTH (int) 0: 440 nm

1: 495 nm 2: 709 nm

3: 800 nm

ATTENUATOR (int) 1 - 99 % of laser power, in 1% step

SWITCH CHANNEL (int) 1 - 80

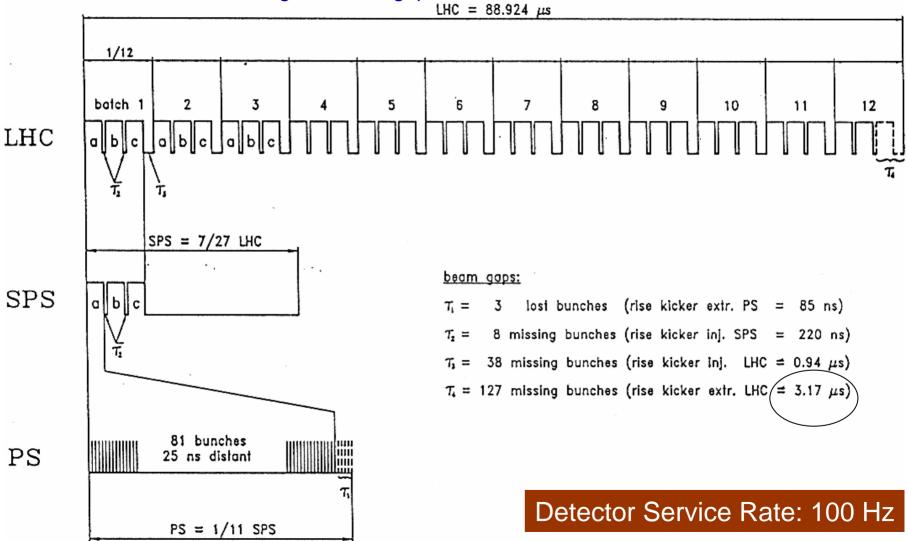
CHECK-SUM (int) Bitwise inversion of the sum of preceding 4 data



IV Continuous monitoring at CMS



Using 1% beam gaps in the LHC beam structure





IV Time needed to scan the ECAL



Time to scan entire ECAL: 30 min (23 sec/channel)

Time needed for channel switching:

With laser DAQ control:

With client communication:

With slow monitor data taking:

With XDAQ control:

1 sec/Channel
2 sec/Channel
4 sec/Channel
unknown

→ Total time: depends on # of events/channel & XDAQ overhead

→ Laser scan may also be controlled by the laser DAQ, not the XDAQ



If so, can the XDAQ handle the laser scan data?

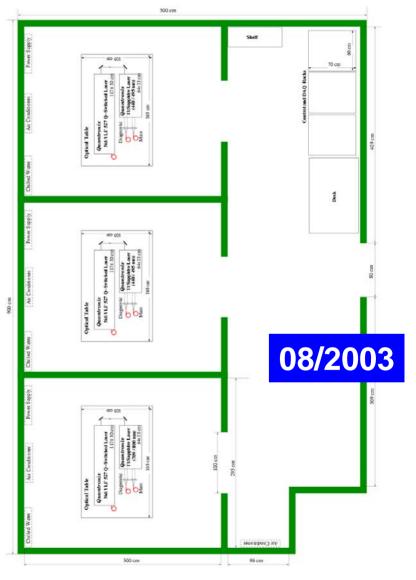


V Laser barracks at H4





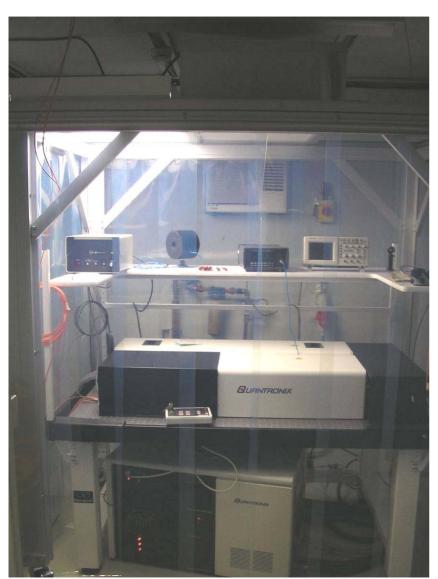






V Softwall clean room facilities





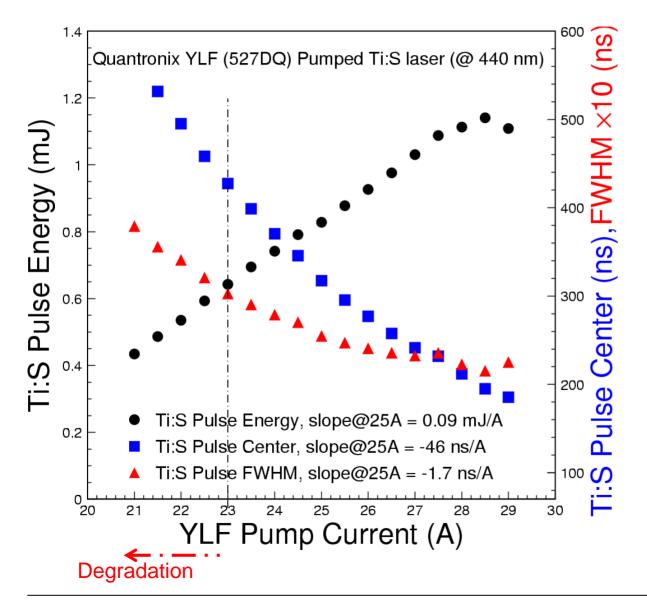
Portable softwall clean room facilities installed in the H4 laser barracks at CERN in Spring, 2005. They provide an environment of better than class 1,000 for laser optics protection (measured at 100)

Laser short/long term stabilities: < 2% and 3%; lamp aging: 0.5% daily. A stable laser pulse would improve monitoring stability.



V Software feedback

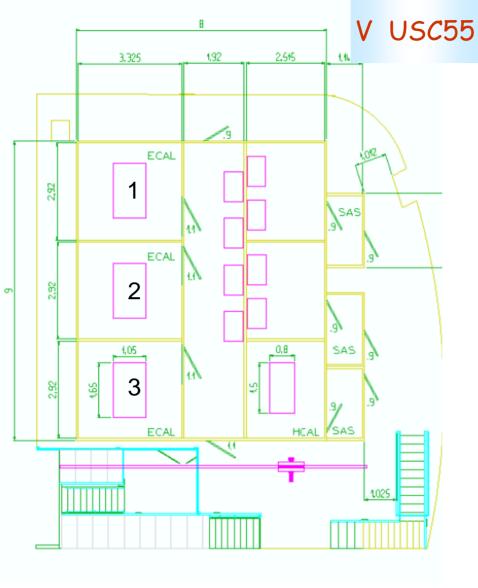




Laser pulse intensity, width and timing are correlated with the pumping current.

Better pulse stability could be achieved by trimming the YLF pumping current.

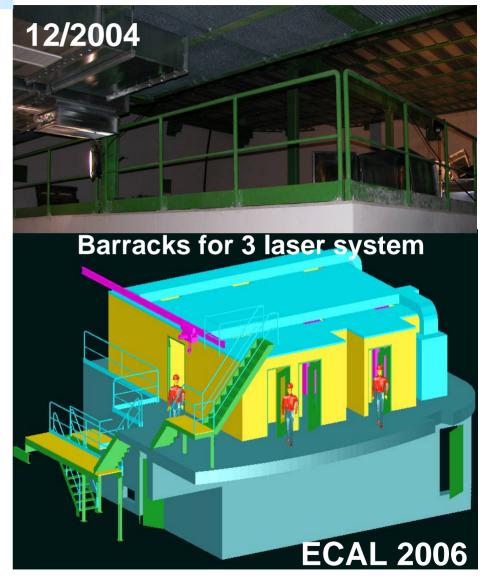
Dr. Kejun Zhu wrote a code, which will be tested by Dr. Liyuan Zhang during his visit at CERN on September 24-28, 2005



Barrack ready for April 2006

New: temperature stability ± 0.5 °C

One laser will be moved to USC55 in 2006?

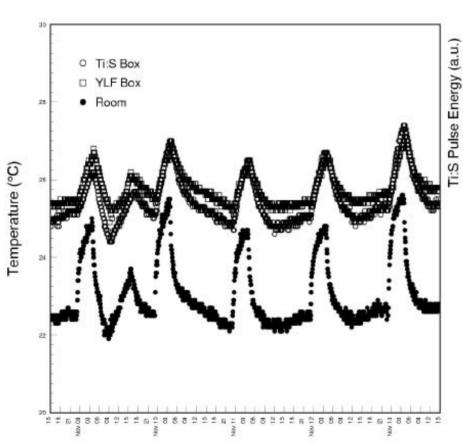


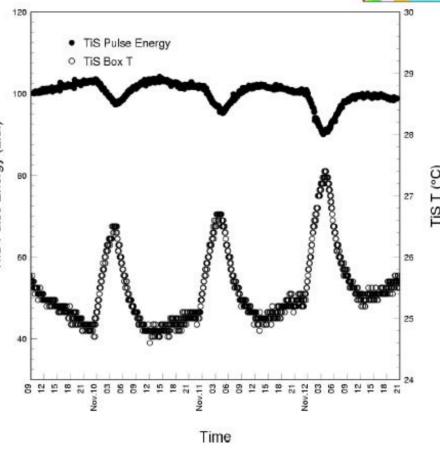


A Study on Temperature Effect



Room T Variations in 5 Days





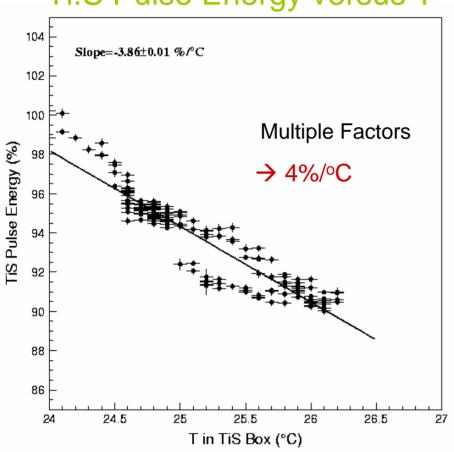
Ti:S Pulse Energy and T



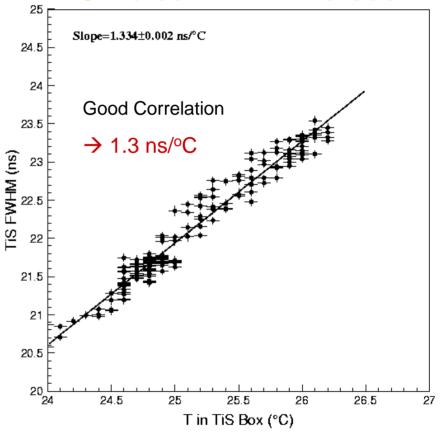
V Temperature dependence



Ti:S Pulse Energy versus T



Ti:S Pulse FWHM versus T





Summary



- Laser performances 440nm:
 - Pulse width: <30ns
 - Pulse jitter: 2 to 4ns
 - Short term (0.5 h) instabilities: <2%
 - Long term (24 h) instability: 3%

Stability getting better with improvement of the environment

- All 3 monitoring systems are consistent
- Laser maintenance: every 40 days minimum

<u>H4</u>: put spare laser online each time? else stop data taking? <u>CMS</u>: need a 1x3 optical switch to reduce the transition time

- > To do list: Software feedback will be tested on September 24-28, 2005,
 - Develop scan software if ECAL scan is controlled by the laser DAQ,
 - Procure a 1x3 switch and a 1x80 switch as spare (broken in July, 05),

For our planning:

Decisions on: - when the laser system is needed at USC55 and

- if we want to keep 2 working laser systems at both H4 and USC55? for how long?

Caltech laser group: Renyuan Zhu (main responsible) - Liyuan Zhang (laser) - Kejun Zhu (software) - Adolf Bornheim (safety+ analysis)

http://laser-caltech.web.cern.ch/laser-caltech/